

# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT** ( Not for submission under 37 CFR 1.99)

Application Number	10530883
Filing Date	2005-04-11
First Named Inventor	Sugawara
Art Unit	2826
Examiner Name	SEFER, AHMED N
Attorney Docket Number	3688KE-1

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Examiner Sefer, Official Action (Restriction Requirement) for U.S. Patent Application No. 11/421,400, mailed August 14, 2007, pages 1-5 (Attorney's Ref. No. 3688KE-1-CON)



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/AS/	1	STAHLBUSH, FEDISON, ARTHUR, ROWLAND, KRETCHMER AND WANG, "Propagation of Current-Induced Stacking Faults and Forward Voltage Degradation in 4H-SiC PiN Diodes", Materials Science Forum, Vols. 389-393 pp. 427-430, 2002 Trans Tech Publications, Switzerland.	<input type="checkbox"/>
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